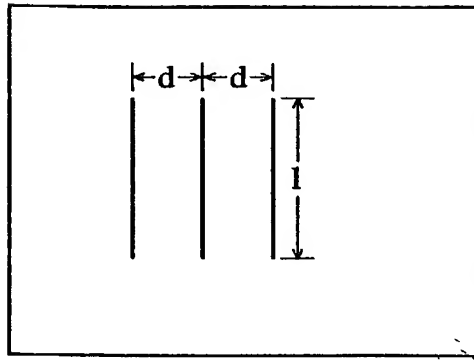


Title: AN ELECTRON BEAM DEVICE AND METHOD FOR STEREOSCOPIC MEASUREMENTS

Inventor(s): Nobuo KOCHI et al.  
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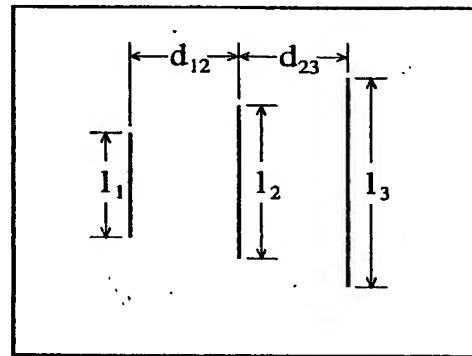
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FIG.1 (A)



0 degree

FIG.1 (B)



10 degrees

FIG.2 (A)

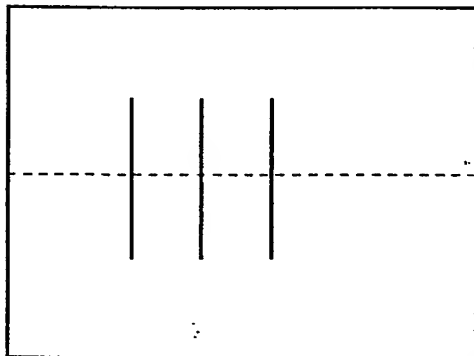
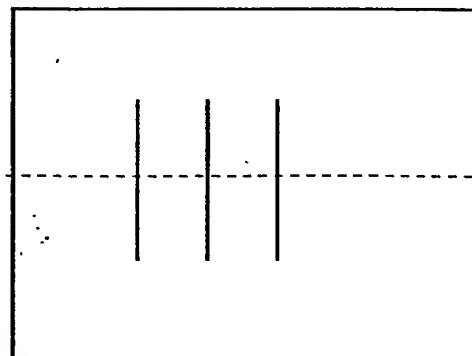


FIG.2 (B)



Epipolar line

FIG.3

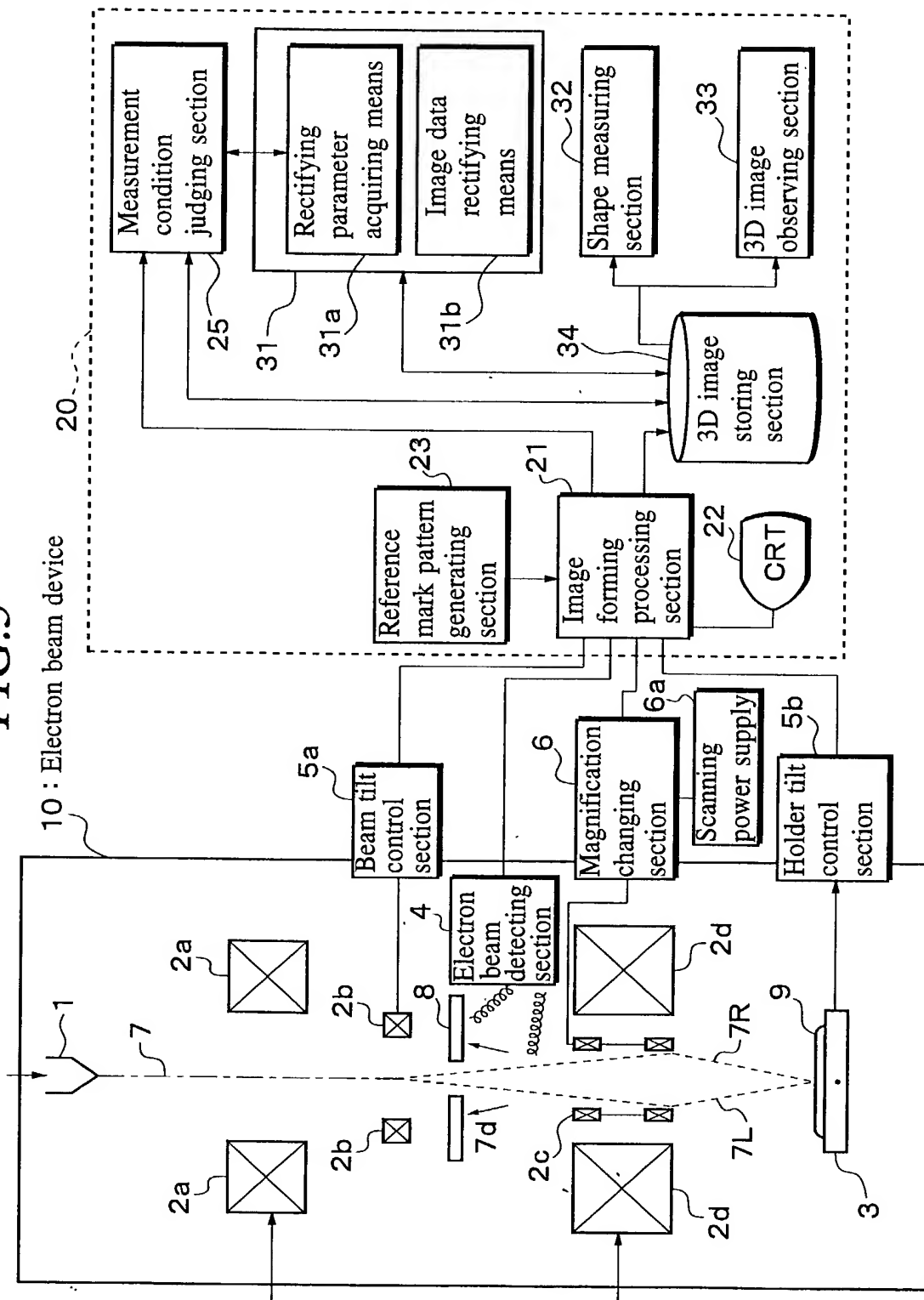


FIG.4 (A)

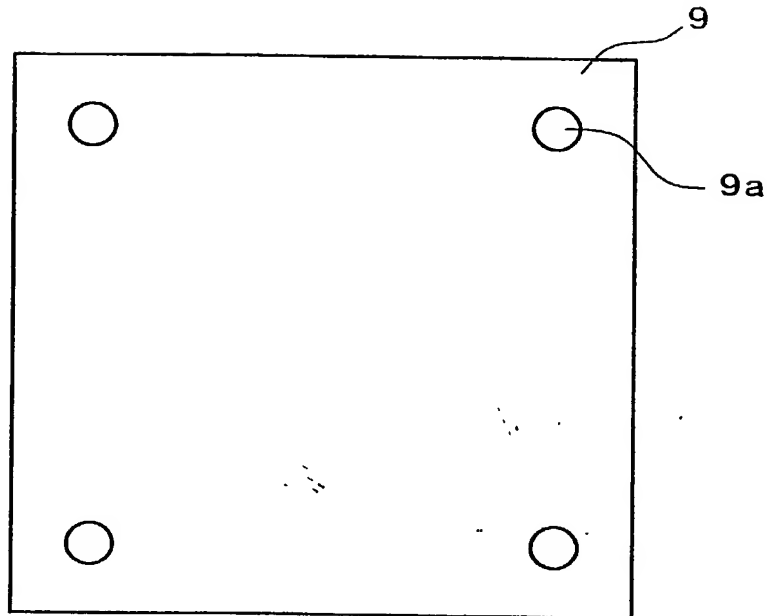


FIG.4 (B)

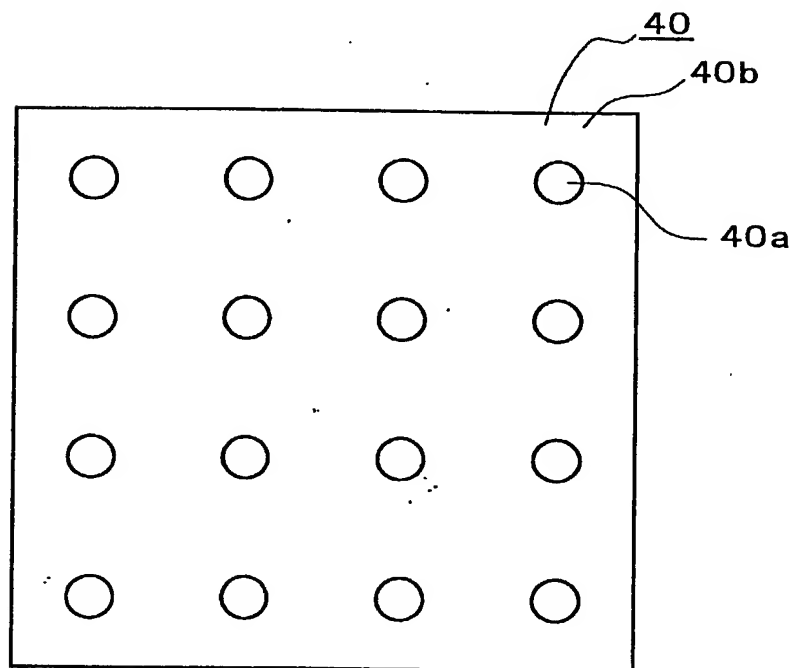
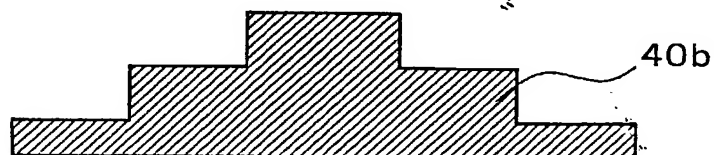
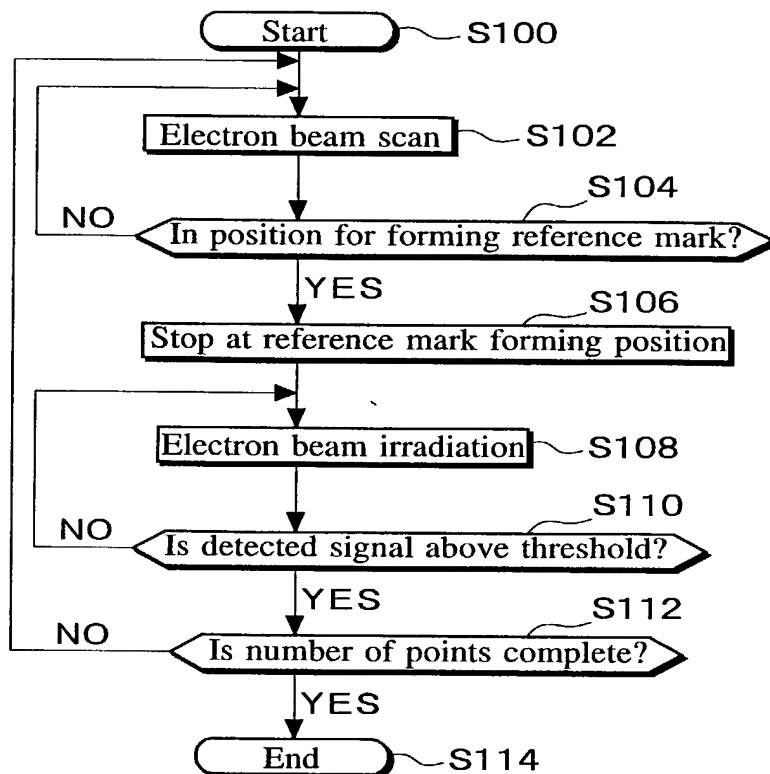


FIG.4 (C)



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FIG.5



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FIG. 6

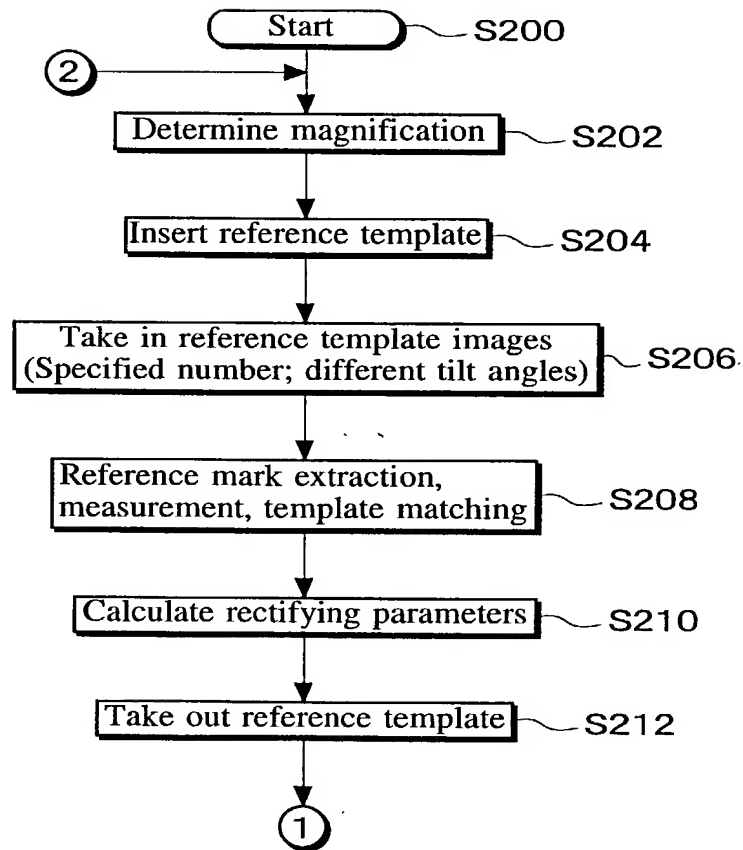
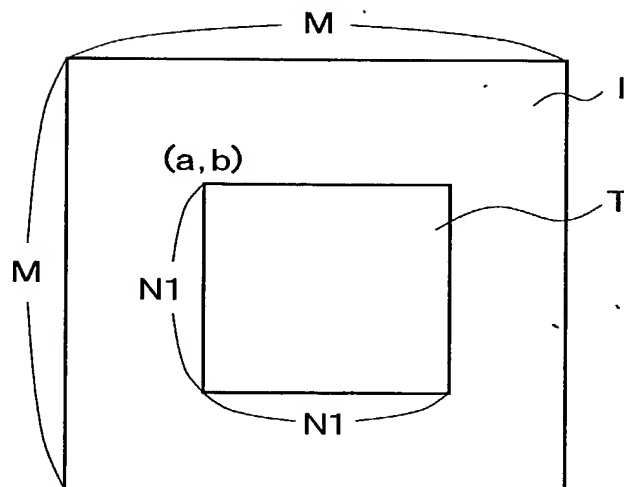
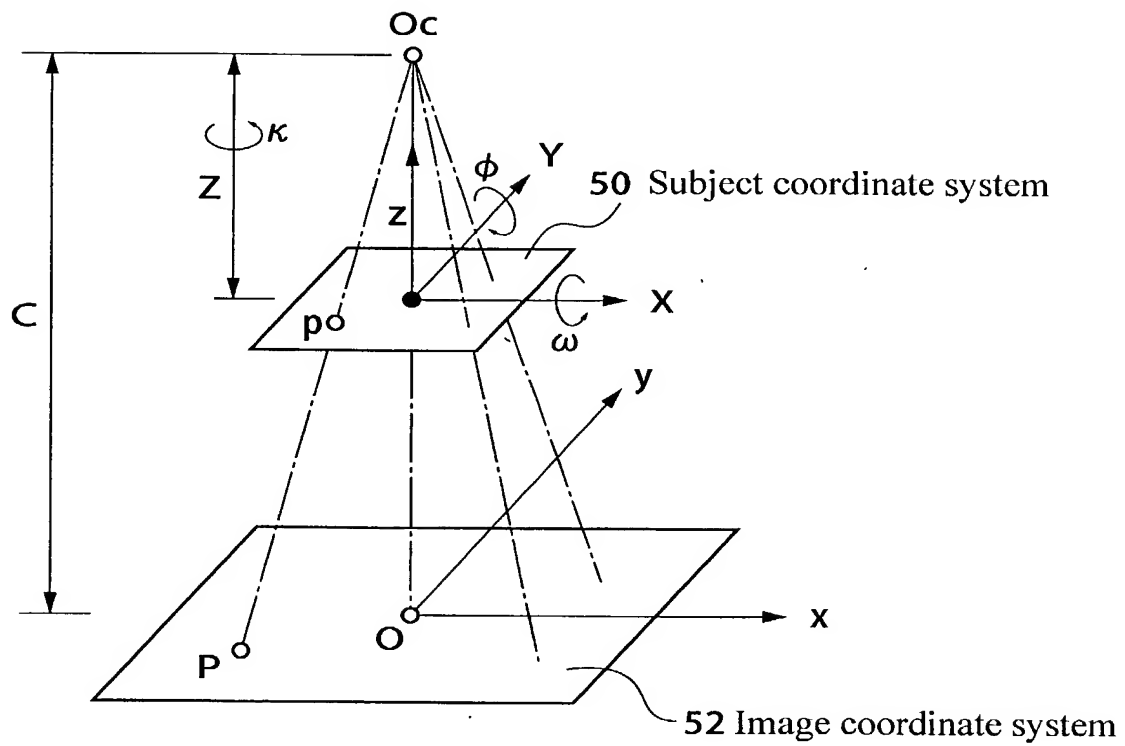


FIG. 7



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FIG. 8

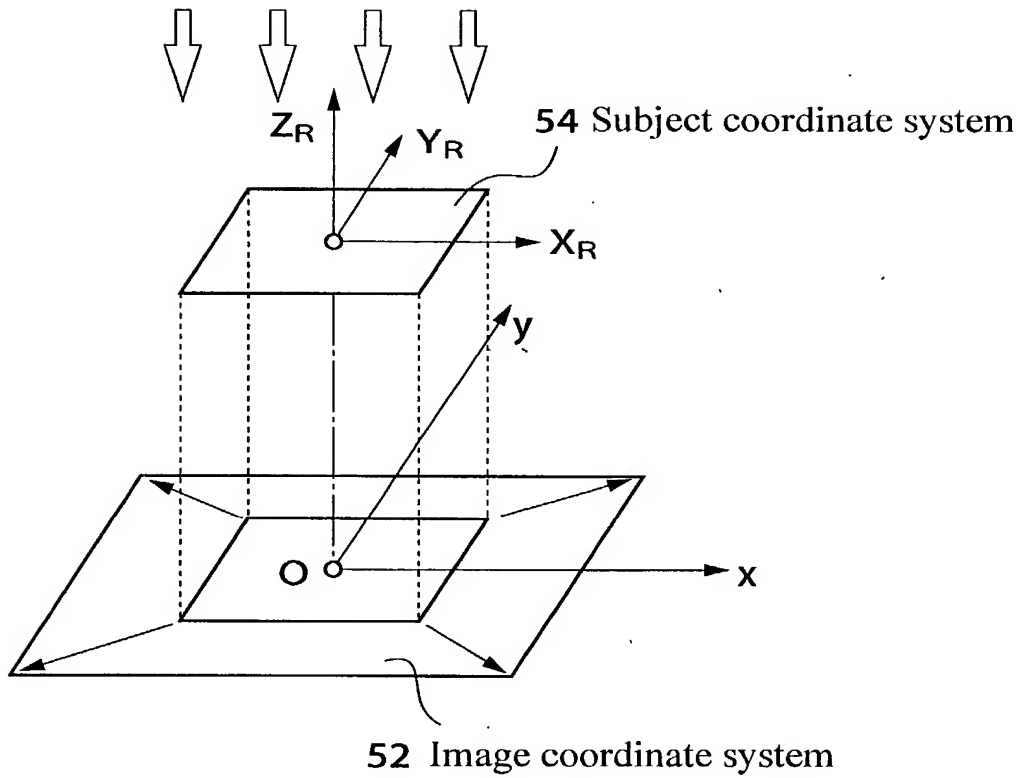


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MEASUREMENTS

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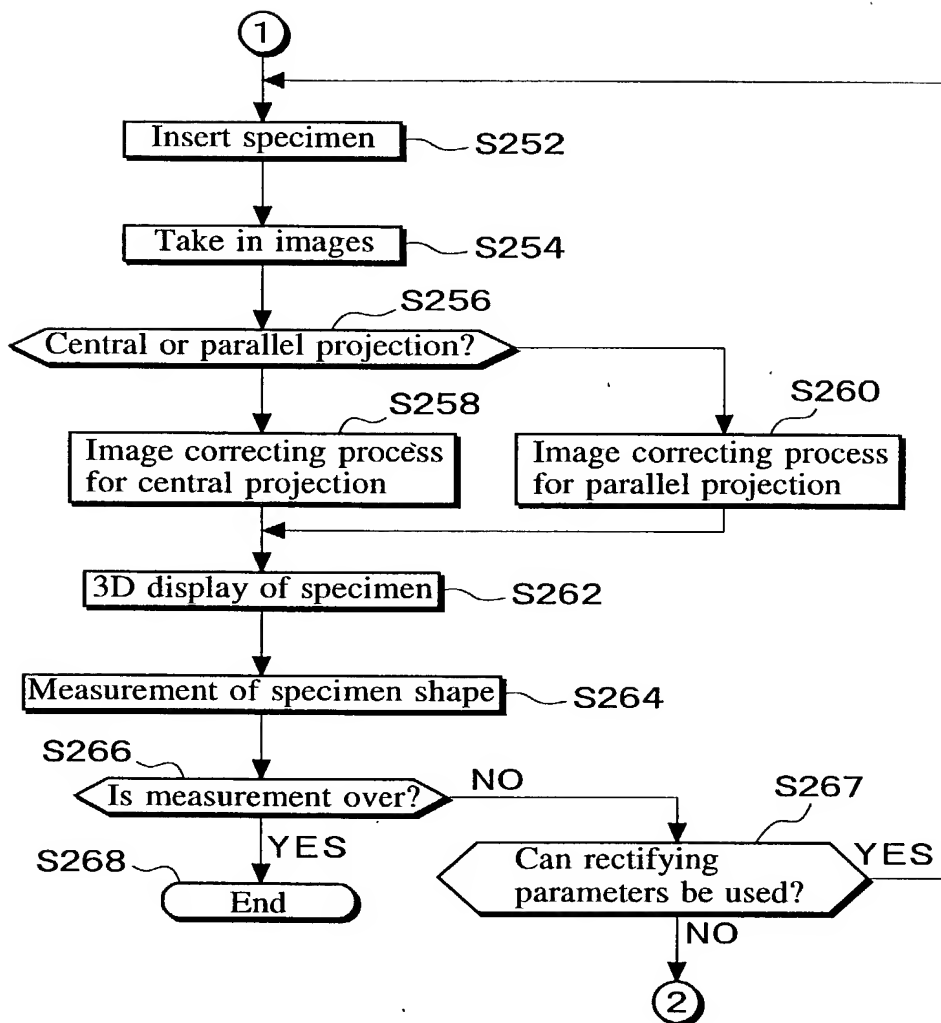
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**FIG. 9**



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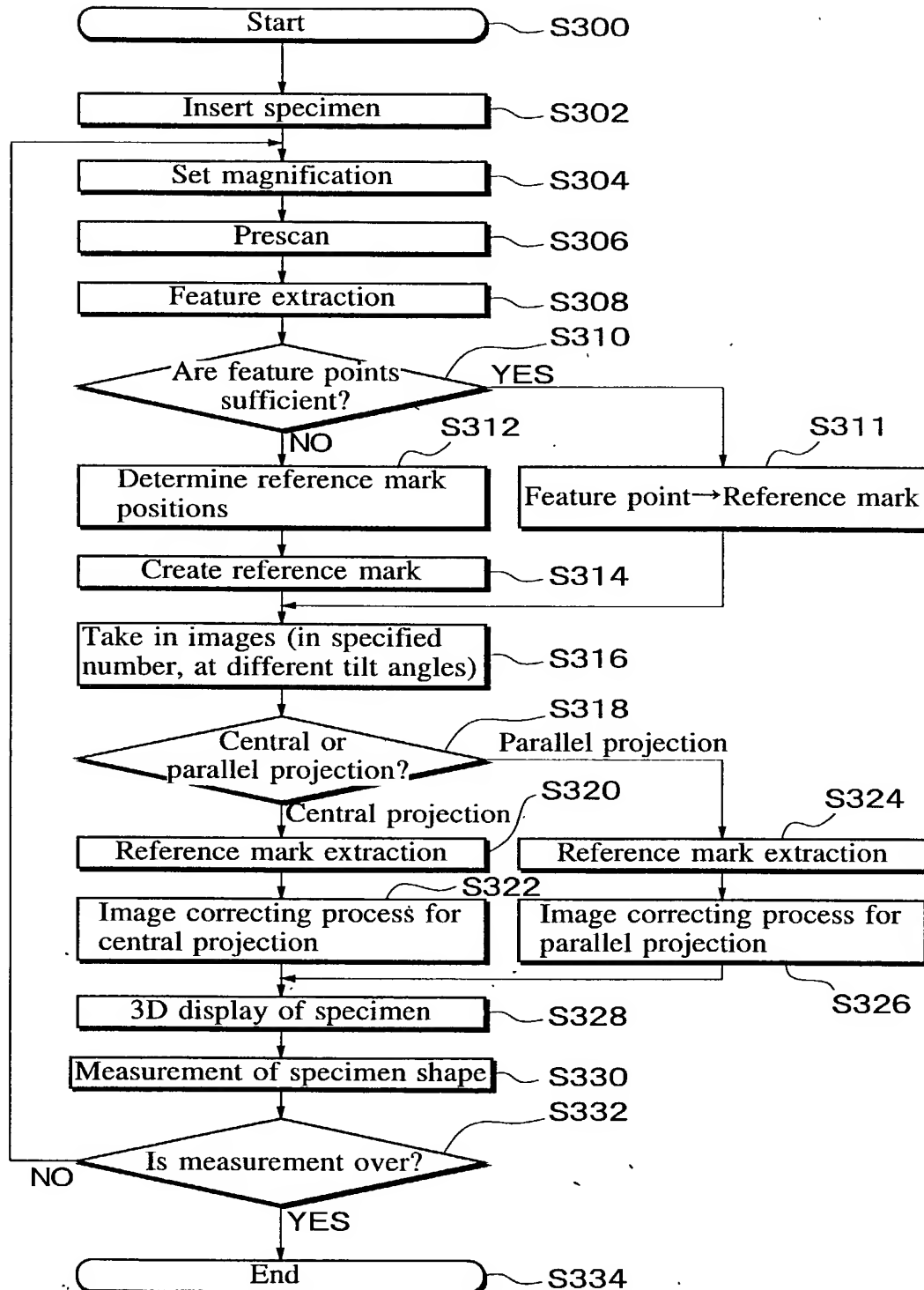
FIG. 10





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FIG.11



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FIG.12 (A)

Laplacean operator

0	-1	0
-1	5	-1
0	-1	0

FIG.12 (B)

Line detecting operator

-1/2	1	-1/2
-1/2	1	-1/2
-1/2	1	-1/2

FIG.13

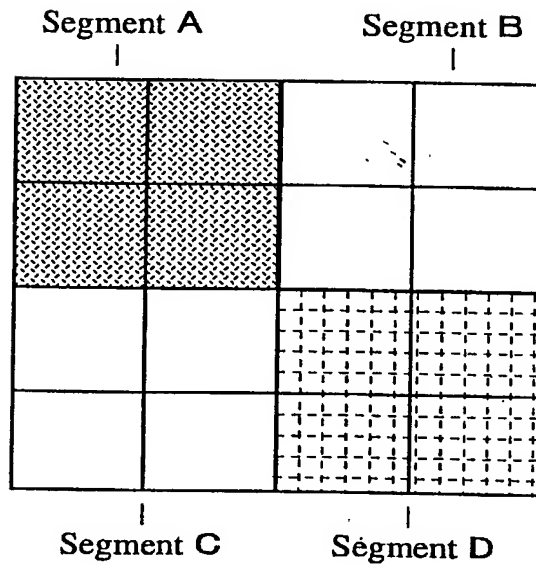


FIG.14

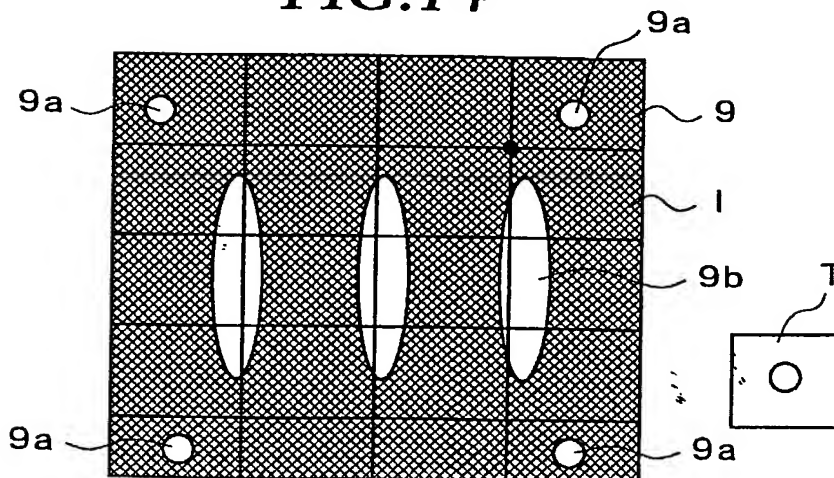


FIG.15

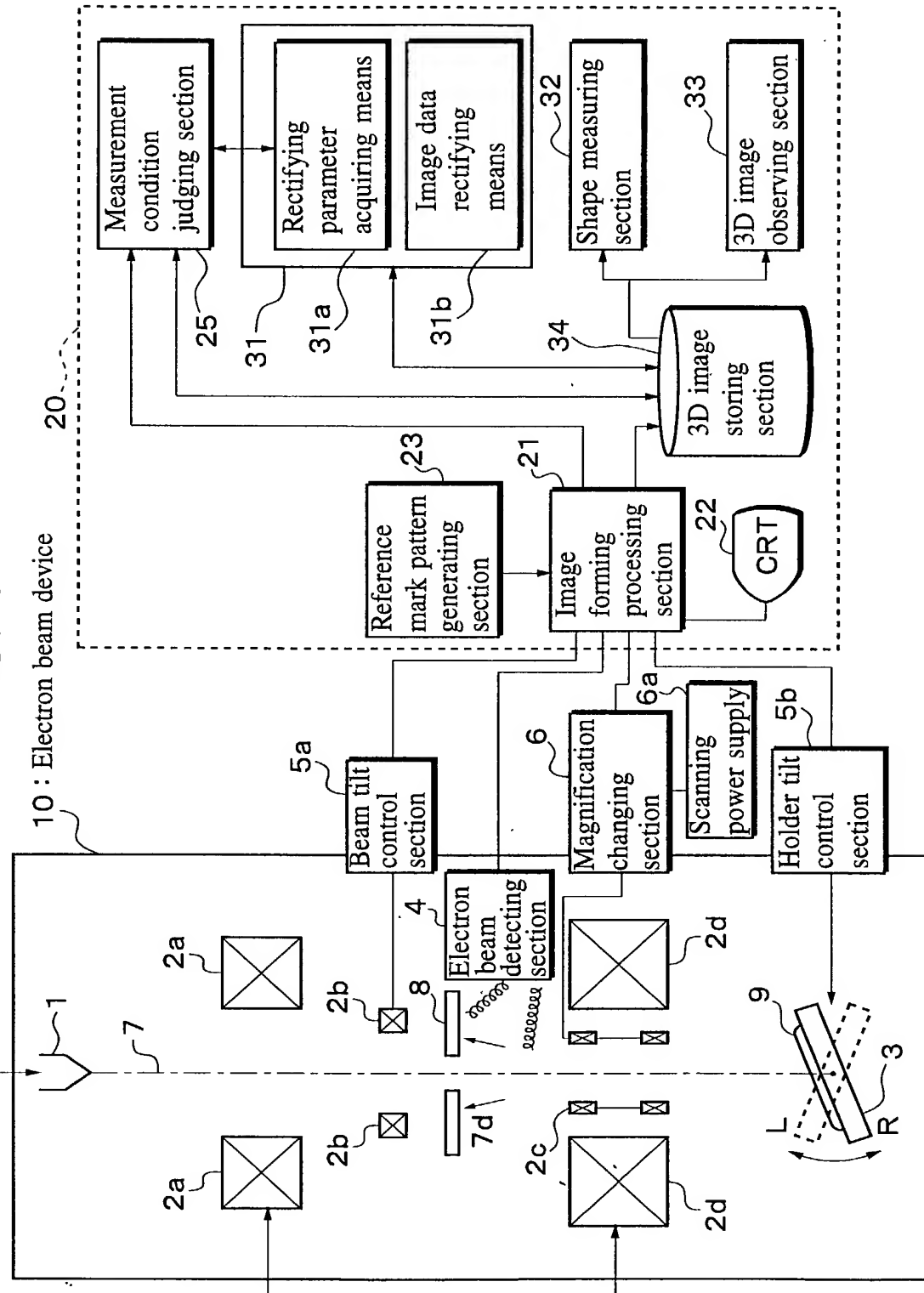


FIG.16

